MICHAEL J. BUJOU)

(ADMITTED IN NIN & ME)

NEAL E. FRIEDMAN

(AI MITTED IN MA)

SCOTT DANIELS

LAW OFFICES

## DAVIS & BUJOLD, P.L.L.C.

FOURTH FLOOR

500 NORTH COMMERCIAL STREET MANCHESTER, NEW HAMPSHIRE 03101 **UNITED STATES OF AMERICA** 

> TELEPHONE (603) 624-9220 FACSIMILE (603) 624-9229 E-mail: patent@davlsandbulold.com

OF COUNSEL

ANTHONY G.M. DAVIS (ADMITTED IN NY ONLY) CHARTER PATENT ACENT (U.K.) EUROPEAN PATENT ATTORNEY

> GARY D. CLAPP (ADMITTED IN MA)

BOSTON ADDRESS: P.O. BOX 67463 **BROOKLINE MA 02467** 

**TECHNOLOGY CENTER 2800** 

# **FACSIMILE TRANSMITTA**

TO: Arnel C. Lavarias		FAX #: (703) 872-9318
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REMARKS AND E	ENCLOSURES:	
In re Appln. of: Serial No.: Filed: For: Group Art Unit: Examiner: Docket:	Kenneth Lloyd WESTRA and Brian MOORE 09/758,715 January 11, 2001 A METHOD OF MAKING A HIGH REFLECTIVITY MICRO MIRROR AND A MICRO MIRROR 2872 Arnel C. Lavarias THOLAM P139US	
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08/12/02

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kenneth Lloyd WESTRA and Brian MOORE

Serial no.

09/758.715

Filed

January 11, 2001

For

A METHOD OF MAKING A HIGH REFLECTIVITY MICRO MIRROR AND A MICRO MIRROR

2872

Group Art Unit

Examiner Docket

Amel C. Lavarias THOLAM P139US

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The Commissioner of Patents and Trademarks

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### RESPONSE

Dear Sir.

This response is being filed in reply to the office action mailed July 15, 2002. In that action, the Examiner has required restriction under 35 U.S.C. 121 between the following groups of claims:

- ١. Claims 1-24, drawn to a method of making a high reflectivity micro mirror, classified in class 216, subclass 2.
- II. Claims 25-62, drawn to a high reflectivity micro mirror, classified in class 359, subclass 838.

In the event that Group I (claims 1-24) is elected, an election of one of the following species is also required:

Species 1:

a method of making a high reflectivity micromirror with the portion of the passage being removed being a passage extending parallel to the

crystalline plane. Claims 1, 2, 7 and 21.

Species 2:

a method of making a high reflectivity micromirror with the portion of the passage being removed being an inlet passage and an outlet passage which intersect at the crystalline plane. Claims 1, 3, 8, 22 and 24.

Species 3:

a method of making a high reflectivity micromirror with the exposed portion of the crystalline plane becoming a part of an exterior surface of the body. Claims 1, 4, 18-23.

Species 4:

a method of making a high reflectivity micromirror with the exposed portion of the crystalline plane remaining positioned internally within the

body. Claims 1 and 5.